

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tomohei SUGIYAMA; Kyoichi KINOSHITA; Takashi YOSHIDA; Hidehiro KUDO; and Eiji KONO
 Serial No.: TBA Group Art Unit: TBA
 Filed: Herewith Examiner: TBA
 For: METHOD OF MANUFACTURING A LOW EXPANSION MATERIAL AND SEMICONDUCTOR DEVICE USING THE LOW EXPANSION MATERIAL

INFORMATION DISCLOSURE STATEMENT

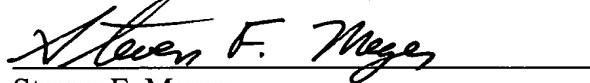
Mail Stop Patent Application
 Commissioner for Patents
 PO Box 1450
 Alexandria, Virginia 22313-1450

Sir:

Pursuant to Rule 56, applicant hereby calls the attention of the Patent Office to the references listed on the attached Form PTO 1449. Copy(ies) of these references are attached were filed in related application U.S. Serial No(s) _____, filed _____, respectively.

- This document is being filed within three (3) months of the filing date of the application
- Please charge the \$180 fee to Deposit Account No. 13-4500, Order No. _____.
- This document is being concurrently filed with the above-identified application
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- The Commissioner is hereby authorized to charge any additional fees which may be required for this Information Disclosure Statement, or credit any overpayment to Deposit Account No. 13-4500, Order No. 5000-5118. A DUPLICATE COPY OF THIS SHEET IS ATTACHED.

Respectfully submitted,
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Dated: July 23, 2003

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